

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)						ATTY. DOCKET NO. 2336-242		U.S. APPLICATION NO. Not yet assigned			
								APPLICANT Sun Woon KIM		10/776,270	
								FILING DATE herewith 2/12/04		GROUP 2818	
U.S. PATENT DOCUMENTS											
EXAMINER'S INITIALS		PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE				
FOREIGN PATENT DOCUMENTS											
EXAMINER'S INITIALS		PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation				
							Yes	No			
TH		WO 00/76004 A1	12/2000	WIPO	/	/	Abstract				
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)											
TH		"Spiral Growth of InGaN Nanoscale Islands on GaN" by Keller et al.; Japanese Journal of Applied Physics, Vol. 37, pgs. L431-434, c. 1998									
EXAMINER					DATE CONSIDERED						
TU TU HIO					Apr - 2005						

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.